

INVENTOR INFORMATION

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CORRESPONDENCE INFORMATION

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APPLICATION INFORMATION

Title Line One:: METHOD OF MANUFACTURING SEMICONDUCTOR DE
Title Line Two:: VICE
Total Drawing Sheets:: 13
Formal Drawings?: Yes
Application Type:: Utility
Docket Number:: 740756-2422
Secrecy Order in Parent Appl.?: No

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22204
Registration Number One:: 38285
Registration Number Two:: 35483
Registration Number Three:: 45285
Registration Number Four:: 32815
Registration Number Five:: 26477

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2001-019293
Filing Date:: 01-26-2001
Country:: Japan
Priority Claimed:: Yes

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